

INVENTOR INFORMATION

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Inventor Two Given Name:: Masahiro
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CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 05514
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APPLICATION INFORMATION

Title Line One:: METHOD FOR FORMING A DEPOSITED FILM BY PLASMA
Title Line Two:: CHEMICAL VAPOR DEPOSITION

Total Drawing Sheets:: 14
Formal Drawings?: Yes
Application Type:: Utility
Docket Number:: 839.449
Secrecy Order in Parent Appl.?: No

REPRESENTATIVE INFORMATION

Representative Customer Number:: 05514

PRIOR FOREIGN APPLICATIONS

Foreign Application One:: 2000-332383
Filing Date:: 10-31-2000
Country:: Japan
Priority Claimed:: Yes

Foreign Application Two:: 2000-332382

Filing Date:: 10-31-2000

Country:: Japan

Priority Claimed:: Yes

2000-332382